#### Attorney Docket No. 219867US8 PATENT APPLICATION First Inventor or Application Identifier Koichi MIYA KI, et al. TRANSMITTAL FERRULE HOLDING APPARATUS AND METHOD FOR MANUFACTURING nly for new nonprovisional applications under 37 CFR 1.53(b)) SEMICONDUCTOR MODULE Assignee Name: THE FURUKAWA ELECTRIC CO., LTD. Assignee Address: 6-1, Marunouchi 2-chome, Chiyoda-ku, Tokyo 100-8322, JAPAN Assistant Commissioner for Patents o APPLICATION ELEMENTS ADDRESS TO: See MPEP chapter 600 concerning utility patent application contents Box Patent Application Washington, DC 20231 Fee Transmittal Form (e.g. PTO/SB/17) 1. 🔯 **ACCOMPANYING APPLICATION PARTS** (Submit an original and a duplicate for fee processing) 7. Assignment Papers (cover sheet & document(s **Total Sheets** 21 8. Application Data Sheet. See 37 CFR 1.76 37 C.F.R. §3.73(b) Statement Power of (when there is an assignee) ☐ Attorney 3. Formal Drawing(s) (35 U.S.C. 113) Total Sheets 16 English Translation Document (if applicable) Information Disclosure Copies of IDS ☐ Citations Statement (IDS)/PTO-1449 Oath or Declaration Total Pages 12. Preliminary Amendment ☐ Newly executed (original or copy) 13. Mhite Advance Serial No. Postcard Copy from a prior application (37 C.F.R. §1.63(d)) Certified Copy of Priority Document(s) b. (for continuation/divisional with box 17 completed) (2) (if foreign priority is claimed) **DELETION OF INVENTOR(S)** ١,٠.] Signed statement attached deleting inventor(s) named in the prior application, see 37 C.F.R. §1.63(d)(2) and Applicant claims small entity status. إيا 15. 🔲 See 37 CFR 1.27 16. M Other: CD-ROM or CD-R in duplicate, large table or Computer Statement re Filing in Foreign Program (Appendix) Language Nucleotide and/or Amino Acid Sequence Submission (if applicable, all necessary) Computer Readable Form (CRF) IJ N b. Specification or Sequence Listing on : [] [] ii. Paper IJ ☐ Statements verifying identity of above copies If a CONTINUING APPLICATION, check appropriate box, and supply the requisite information below: Continuation □ Divisional ☐ Continuation-in-part (CIP) of prior application no.: Prior application information: Examiner: Group Art Unit: For CONTINUATION OR DIVISIONAL APPS only: The entire disclosure of the prior application, from which an eath or declaration is supplied under Box 4b, is considered a part of the accompanying continuation or divisional application and is hereby incorporated by reference. The incorporation can only be relied upon when a portion has been inadvertently omitted from the submitted application parts. 18. Amend the specification by inserting before the first line the sentence: ☐ This application is a ☐ Continuation □ Division ☐ Continuation-in-part (CIP) of application Serial No. Filed on ☐ Which was published in English ☐ Which was not published in English ☐ This application claims priority of provisional application Serial No. Filed 19. CORRESPONDENCE ADDRESS



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Name:	C. Irvin McClelland Registration Number 21,124	Registration No.:	

Docket No.

219867US8

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) Koichi MIYAZAKI, et al.

SERIAL NO:

New Application

FILING DATE: Herewith

FOR:

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FERRULE HOLDING APPARATUS AND METHOD FOR MANUFACTURING SEMICONDUCTOR

**MODULE** 

## FEE TRANSMITTAL

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

FOR	NUMBER FILED	NUMBER EXTRA	RATE	CALCULATIONS
TOTAL CLAIMS	15 - 20 =	0	× \$18 =	\$0.00
INDEPENDENT CLAIMS	6 - 3 =	3	× \$84 =	\$252.00
☐ MULTIPLE DEPENDENT CLAIMS (If applicable)			+ \$280 =	\$0.00
☑ LATE FILING OF DECLARATION			+ \$130 =	\$130.00
	\$740.00			
	\$1,122.00			
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\$1,252.00 to cover the filing fee is enclosed.

The Commissioner is hereby authorized to charge any additional fees which may be required for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Date:

2/20/02

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Docket No.

219867US8

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Koichi MIYAZAKI, et al.

SERIAL NO.

**NEW APPLICATION** 

FILING DATE: HEREWITH

FOR:

FERRULE HOLDING APPARATUS AND METHOD FOR MANUFACTURING SEMICONDUCTOR

MODULE

#### STATEMENT RE FILING IN FOREIGN LANGUAGE

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

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<u>|</u>== It is hereby stated that the subject application is being filed in a foreign language, in accordance with the provisions egf 37 CFR 1.52(d).

An accurate English translation, and a suitable amendment placing the application and claims thereof into proper Ü.S. format if needed, will be filed in due course.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Bradley D. Lytle

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